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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hitoshi FUKUSHIMA et al.

Art Unit : 1627

Serial No. : 09/163,199

Examiner : M. Garcia

Filed : September 30, 1998

Title : MANUFACTURE OF A MICROSENSOR DEVICE AND A METHOD FOR
EVALUATING THE FUNCTION OF A LIQUID BY THE USE THEREOF

TECH CENTER 1600/2900

Commissioner for Patents
Washington, D.C. 20231

RESPONSE

In response to the action mailed November 13, 2001, please amend the application as follows:

In the claims:

Please cancel claims 2 and 19.

Please amend claim 1 as follows:

Sub
C3
B1

--1. A method of manufacturing a sensor device comprising a circuit having organic thin films formed on electrodes, and a transducing element capable of transducing information recognized by the organic thin films into electric signals, the method comprising:

printing a solution of thin film material as micro-dots onto surfaces of microelectrodes such that organic thin films are formed on the microelectrodes, wherein the solution of thin film material comprises a composition resulting from dissolution of an electro-conductive polymer in a solvent.--